

## Influence of $\beta$ -Silyl Groups in Cycloalkanones on the Norrish Type I and Type II Cleavages

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The Norrish type I cleavage overwhelms the type II cleavage in the photolysis of  $\alpha$ -alkylcycloalkanones bearing an SiMe<sub>3</sub>, SiMe<sub>2</sub>Ph, SiMePh<sub>2</sub>, or SiPh<sub>3</sub> group at the  $\beta$  position, of which the quantum yields are often greater than those of the non-silylated cycloalkanones.

The Norrish type I cleavage provides a valuable tool in organic synthesis<sup>1</sup> and a photochemical pathway to degrade carbonyl compounds.<sup>2</sup> The Norrish type II cleavage usually prevails over the type I cleavage during the photolysis of cycloalkanones bearing a  $\gamma$  hydrogen on an  $\alpha$  side chain. Examples include the photolysis of  $\alpha$ -alkylcyclohexanones **1–3**,<sup>3</sup> from which the ratios of products are 0.3–1.0 for type I/type II. To intensify the type I cleavage and ultimately to force it to be the major pathway, we searched for a special moiety that can stabilize the radical intermediate generated in the type I process.

Use of a  $\beta$ -SiMe<sub>3</sub> group to direct the Norrish type I cleavage of cycloalkanones was first reported in early 1990.<sup>4</sup> This new reaction was soon applied in organic synthesis.<sup>5–8</sup> Herein we report our new findings that various organosilyl groups can promote Norrish type I cleavage to occur as the major pathway in cycloalkanones bearing a  $\gamma$  hydrogen on an  $\alpha$  side chain.

$\alpha$ -Alkyl- $\beta$ -(trimethylsilyl)cyclohexanones **4a–6a** (cf. the corresponding non-silylated cycloalkanones **1–3**) possess a primary, secondary, and tertiary  $\gamma$  hydrogen, respectively. We irradiated these cycloalkanones in anhydrous methanol containing 1.3 equiv. of NaHCO<sub>3</sub> with UV light ( $\lambda > 3000$  Å). Distribution of the type I products, including aldehydes **4b–6b** and esters **4c–6c**, and the type II product **16** is summarized in Scheme 1 and Table 1 (entries 4–6). In all of these reactions, the major products came from type I cleavage (type I/type II = 2.1–4.9). We also found that the quantum yields<sup>9</sup> for  $\beta$ -silylated cycloalkanones were always greater than those of the corresponding non-silylated cycloalkanones (see Table 1). We then

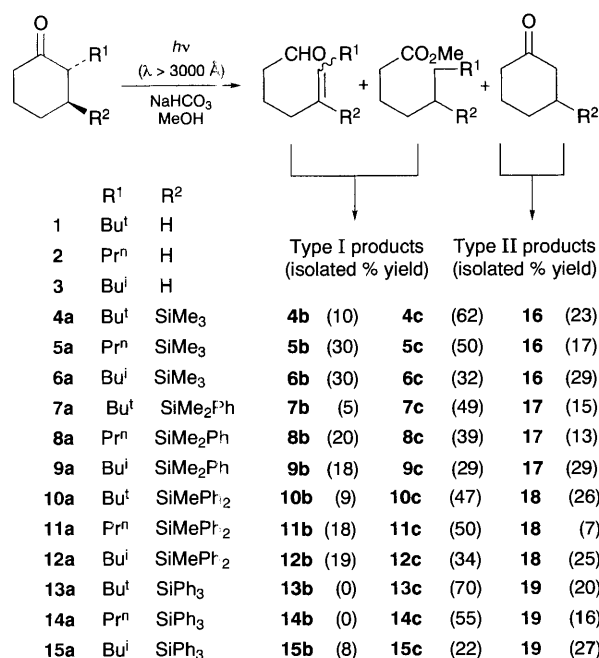
attached various silyl groups, including SiMe<sub>2</sub>Ph, SiMePh<sub>2</sub>, and SiPh<sub>3</sub>, onto  $\alpha$ -alkylcycloalkanones. The major products obtained by irradiation of those silylcycloalkanones **7a–15a** came from type I cleavage (Table 1).

Our results indicate that organosilyl groups presented a different influence on the product distribution from type I and type II cleavages. All of the four groups, SiMe<sub>3</sub>, SiMe<sub>2</sub>Ph, SiMePh<sub>2</sub> and SiPh<sub>3</sub>, at the  $\beta$  position in  $\alpha$ -alkylcycloalkanones were able to force type I cleavage to be the major photolytic pathway regardless of the  $\gamma$  hydrogen on the  $\alpha$  side chain being primary, secondary, or tertiary (Table 1, third column, entries 4–15). The highest ratio for type I/type II was 9.7, which was obtained by use of the SiMePh<sub>2</sub> group (entry 11). In comparison with the ratio of 0.5 in the photolysis of the corresponding non-silylated cyclohexanone **2** (entry 2), the influence from the SiMePh<sub>2</sub> group was  $\approx 20$  fold.

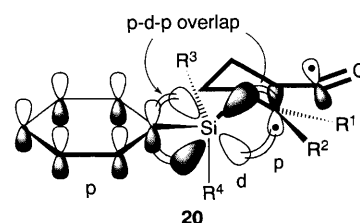
We found that the quantum yields for cyclohexanones bearing a  $\beta$ -SiMe<sub>3</sub>, -SiMe<sub>2</sub>Ph, or -SiMePh<sub>2</sub> group were 1.3–8.9 times higher than those of the non-silylated cycloalkanones (Table 1, entries 4–12). Among those silyl groups, SiMe<sub>2</sub>Ph showed the most remarkable effect (entry 8). Our results in Table 1 revealed that, in comparison with the SiMe<sub>3</sub> group, a silicon atom attached with a phenyl group often exhibited greater influence on quantum yields of Norrish type cleavages.

**Table 1** Comparison of the product distributions and quantum yields ( $\Phi$ ) in the photolysis of  $\beta$ -silylated and non-silylated cyclohexanones through the Norrish type I and type II cleavages

Entry	Cycloalkanone	Product ratio Type I/Type II	Quantum yield ( $\Phi$ )	$\Phi_{Si}/\Phi_{parent}$
1	<b>1</b>	1.0	0.120	—
2	<b>2</b>	0.5	0.082	—
3	<b>3</b>	0.3	0.070	—
4	<b>4a</b>	3.1	0.151	1.3
5	<b>5a</b>	4.9	0.124	1.5
6	<b>6a</b>	2.1	0.106	1.5
7	<b>7a</b>	3.6	0.464	3.9
8	<b>8a</b>	4.5	0.728	8.9
9	<b>9a</b>	1.6	0.390	5.6
10	<b>10a</b>	2.2	0.258	2.2
11	<b>11a</b>	9.7	0.246	3.0
12	<b>12a</b>	2.1	0.118	1.7
13	<b>13a</b>	3.6	0.041	0.34
14	<b>14a</b>	3.7	0.068	0.83
15	<b>15a</b>	1.1	0.165	2.4



**Scheme 1** Photolysis of  $\beta$ -silylcyclohexanones to give a mixture of products from the Norrish type I and type II processes



A silyl group can stabilize a  $\beta$ -carboradical through ' $\sigma$ - $\pi$  hyperconjugation'<sup>10-13</sup> or ' $p$ - $d$  homoconjugation'<sup>14,15</sup> or both. We believe that the  $p$  orbitals in the phenyl group could enhance ' $p$ - $d$  homoconjugation' resulting from the silicon atom by offering ' $p$ - $d$ - $p$  homoconjugation' to stabilize the  $\beta$ -carboradical. Structure 20 depicts the ' $p$ - $d$ - $p$ ' orbital overlap among a phenyl ring, a silicon atom, and a carboradical.

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